

PATENT



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Danilo Mascolo et al.  
 Application No. : 10/695,479  
 Filed : October 28, 2003  
 For : SINGLE ELECTRON TRANSISTOR MANUFACTURING  
 METHOD BY ELECTRO-MIGRATION OF METALLIC  
 NANOCLUSTERS

Examiner : David Nhu  
 Art Unit : 2818  
 Date of Notice  
 of Allowance : April 6, 2005  
 Docket No. : 856063.754  
 Date : July 5, 2005

Mail Stop Issue Fee  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

*4/7/05  
Approved  
D*

AMENDMENT AFTER ALLOWANCE  
(UNDER 37 CFR 1.312)

Commissioner for Patents:

In response to the Notice of Allowance dated April 6, 2005, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Drawings** begin on page 3 of this paper and includes attached Replacement Sheets.

**Remarks/Arguments** begin on page 4 of this paper.